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02/10/2005 14:49 FAX 5098383424 WELLS ST JOHN PS 002/006

Practitioner's Docket No. MIZZ-2391 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Werner Jaengling

Application No.: 10678,513 Group No.: 2823
 Filed: 10/03/03 Examiner: B. Kebode

For: Semiconductor Processing Methods of Forming a Contact Opening to a Conductive Line and Methods of Forming Substrate Active Area Source/Drain Regions

Commissioner for Patents
 Washington, D.C. 20231

CERTIFICATION OF FACSIMILE TRANSMISSION

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Facsimile Transmittal
 Supplemental Information Disclosure Statement
 PTO-Form 1469

2/10/05 Robin Saldiva
RS *LL*
 Signature

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(Confirmation of Facsimile Transmission-Page 1 of 1)

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/678,513
Filing Date October 3, 2003
Inventor Werner Juengling
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner B. Kebede
Attorney Docket No. MI22-2391
Title: Semiconductor Processing Methods of Forming a Contact Opening to a Conductive Line and Methods of Forming Substrate Active Area Source/Drain Regions

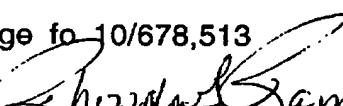
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Washington, D.C. 20231

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3. Copy of Supplemental Information Disclosure Statement of 2/10/05
4. Copy of PTO-Form 1449 of 2/10/05
5. Copy of page 1, PAIR Information page for 10/678,513

Dated: 22 Sept 2005

By: 
Rhonda G. Rambo
Telephone No. (509) 624-4276

NUMBER OF PAGES IN FACSIMILE: 6

NOTE: According to our records; our PTO Deposit Account (number 23-0925) has not been charged \$180.00 for the Supplemental Information Disclosure Statement filed on 2/10/05. Please verify your records; according to the PAIR information page, the USPTO has noted the Supplemental Information Disclosure Statement was filed on 2/10/05.

Regards,


Rhonda

Practitioner's Docket No. MI22-2391

COPY PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Werner Juengling

Application No.: 10/678,513
Filed: 10/03/03Group No.: 2823
Examiner: B. Kebede

For: Semiconductor Processing Methods of Forming a Contact Opening to a Conductive Line and Methods of Forming Substrate Active Area Source/Drain Regions

Commissioner for Patents
Washington, D.C. 20231

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Robin Saldivia



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/678,513
 Filing Date October 3, 2003
 Inventor Werner Juengling
 Assignee Micron Technology, Inc.
 Group Art Unit 2812
 Examiner B. Kebede
 Attorney's Docket No. MI22-2391
 Customer No. 021567

Title: Semiconductor Processing Methods of Forming a Contact Opening to a Conductive Line and Methods of Forming Substrate Active Area Source/Drain Regions

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References --See Attached Form PTO-1449

The attached Form PTO-1449 is submitted in compliance with 37 C.F.R. §§ 1.56. Pursuant to Federal Register Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art references are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

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Respectfully submitted,

Dated: 2-10-05

By: 

D. Brent Kenady
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LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT Werner Juengling					
COPY		FILING DATE October 3, 2003		GROUP 2823			
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date (If Appropriate)
	AA	5,631,182	05/20/97	Suwanai et al.			
	AB						
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	AN						No
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